

Title (en)

NOVEL METHOD FOR MANUFACTURING ORGANIC ELECTRONIC DEVICES

Title (de)

NEUARTIGES VERFAHREN ZUR HERSTELLUNG ORGANISCHER ELEKTRONISCHER VORRICHTUNGEN

Title (fr)

NOUVEAU PROCÉDÉ DE FABRICATION DE DISPOSITIFS ÉLECTRONIQUES ORGANIQUES

Publication

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Application

**EP 13792767 A 20131108**

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- IB 2013060000 W 20131108

Abstract (en)

[origin: WO2014072944A1] The present invention relates to a method for manufacturing organic electronic devices including a dipyranylidene film as an anodic interface layer, said method being carried out in a vacuum and without any exposure to air. The invention also relates to organic devices resulting from said method, more specifically to organic solar cells (OSC).

IPC 8 full level

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